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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10071207	FILING DATE 02/11/2002	CLASS 438 257	SUBCLASS 211	GAU 2811	EXAMINER GUERRERO
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**APPLICANTS: Kluth George; Xiang Qi; 2822

OK MG
**CONTINUING DATA VERIFIED:
THIS APPLN CLAIMS BENEFIT OF 60/267,407 02/09/2001

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NONE MG
** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	ATTORNEY DOCKET NO 52352-785
35 USC 119 conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	
Verified and Acknowledged Examiners's initials	MG	
TITLE : Method of manufacturing a semiconductor device with supersaturated source/drain extensions and metal silicide contacts		

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
Primary Examiner		Application Examiner	
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